

SNU Status

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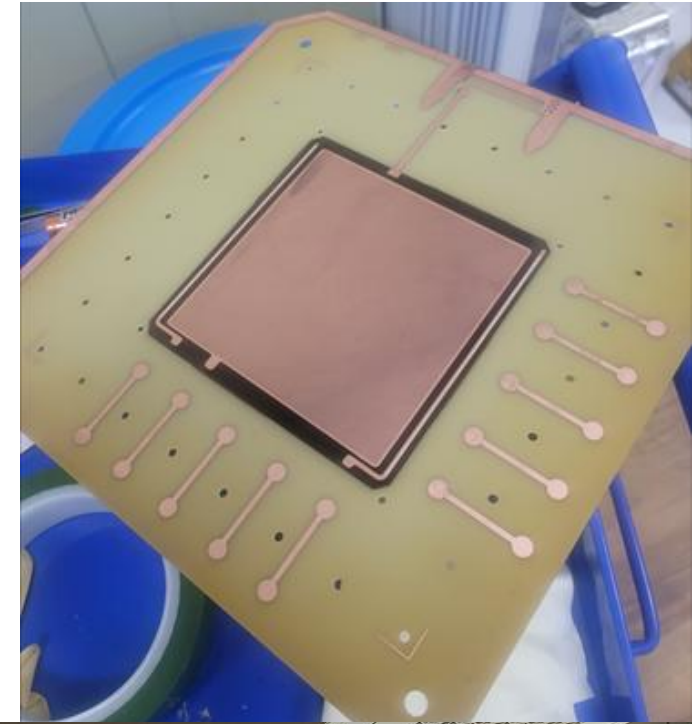
MPGD DSC

1. New Student

- Hyeonjin Lee
 - PhD. student

2. 10x10 μ RWELL status

- Prototype production done
- We will begin the HV stability test shortly
 - Since the IBS cleanroom will be occupied by CMS foil production for another one to two months, I'm currently searching for an alternative location
 - I found an unused cleanroom at SNU and are I'm trying to get permission
- An oven (50cm * 50cm * 60cm (h)) has also been prepared and is ready for use



3. DLC sputtering study

- Although this study does not specifically target the ePIC ECT...
 - However, my long-term goal is to establish domestic production of DLC-FCCL to gain greater flexibility in scheduling and logistics
- I met with a company specializing in DLC sputtering, which is conveniently located a 5-minute drive from the etching site
 - [Link](#)
 - They already specialize in using DLC for resistive coatings in applications such as secondary batteries
 - Their capabilities range from 60cm x 60cm coatings for R&D purposes to large-area coatings of 1.2m x 2.5m using their larger sputtering equipment
 - I plan to plot the resistivity of the DLC-FCCL as a function of the DLC thickness

σ-DLC

σ-DLC coating is a DLC coating with electrical conductivity or electrical insulation through electrical resistance control.

It can be applied to fields that require insulation, such as secondary batteries and biosensors, and parts that require conductivity, such as measuring instruments and displays.

Coating	Processing temp	Electrical resistance	Hardness	coefficient of friction	Max temp of application	Major characteristics
σ-DLC	< 250 °C	~10 ³ ~ 10 ¹⁰ Ω/cm ²	2,100 HV	< 0.2	450 °C	Conductivity



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